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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use several sheets if necessary)

APPLICANT Strauss et al.

FILING DATE June 25,

GROUP 1109

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EXAMI		PATENT NUMBER		ISSUE DATE	PATENTEE	DEC 19 CLASS	199/ SUBCLASS	FILING DATE IF APPROPRIATE					
p	 A.A	4	8	2	0	3	9	7	4/1989	Fielder $ u$	204	298.12	n/a
	A.B	4	8	5	5	0	3	3	8/1989	Hurwitt	204	298	n/a
	A.C	5	0	0	9	7	6	5	4/1991	Qamar et al.	204	298.12	n/a
	A.D	5	0	6	6	3	8	1	11/91	Ohta et al.	204	298.12	n/a
	A.E	5	1	4	3	5	9	0	9/92	Strothers et al.	204	298.12	n/a
l	A.F	5	1	4	7	5	2	1	9/1992	Belli et al.	204	298.12	n/a
	 A.G	5	2	5	9	9	4	1	11/93	Münz	204	298.09	n/a
	A.H	5	2	6	9	4	0	3	12/1993	Pouliquen et al.	204	298.12	n/a
	A.I	5	5	2	9	6	7	3	6/96	Strauss et al.	204	298.12	n/a
V	A.J	5	6	4	1	3	8	9	6/97	Strauss et al.	204	298.12	n/a
	A.K												

FOREIGN PATENTS OR PUBLISHED FOREIGN PATENT APPLICATIONS

		DOCUMENT NUMBER	PUBLICATION DATE	COUNTRY OR PATENT OFFICE	CLASS	SUBCLASS	TRANSLATION (YES/NO)
m	A.L	2-285069	11/1990	Japan	204	298.12	no
offen	A.M	92-20831	11/1992	PCT -	?	?	yes
	A.N						
	A.0						
	A.P				i		
	D.A						

OTHER DOCUMENTS (Including Author, Title, Date, Place of Publication)

Ym	A.R	Tokyo Electron KK, <u>Sputtering Device Has Readily Replaceable Target</u> , English Abstract, Japanese Document 2-285069
pu	A.S	Murata Seisakusho KK, <u>Target For Sputtering</u> , English Abstract, Japanese Document 55-89471
	A.T	

EXAMINER

DATE CONSIDERED 7-98

EXAMINER: Initial if citation considered, whether or not in conformance. Draw line through citation only if not in conformance and not considered. Include a copy of this form with next communication to applicant.